

IPW



00862.023280

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Shinji UCHIDA

Application No.: 10/693,104

Filed: October 27, 2003

For: POSITIONING APPARATUS AND
CHARGED-PARTICLE-BEAM EXPOSURE
APPARATUS

)
: Examiner: D. D. Le
)
: Group Art Unit: 2834
)
: Confirmation No.: 1628
)
:
) February 14, 2005
: (Monday)
)

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Official Action dated November 12, 2004, please amend the above-identified application as follows: